

## PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
Masatoshi Echigo	12/18/2012
RECEIVING PARTY DATA	
Name:	Mitsubishi Gas Chemical Company, Inc.
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Internal Address:	Chiyoda-ku
City:	Tokyo
State/Country:	JAPAN
Postal Code:	100-8324
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	13812831
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NAME OF SUBMITTER:	Stephen S. Favakeh
Total Attachments: 2	
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CH \$40.00 13812831

ASSIGNMENT

I, ECHIGO, Masatoshi of Hiratsuka-shi, Kanagawa, Japan, for good and valuable consideration, receipt of which is hereby acknowledged, have assigned and do hereby assign to MITSUBISHI GAS CHEMICAL COMPANY, INC., a Japanese company, having its principal place of business at 5-2, Marunouchi 2-chome, Chiyoda-ku, Tokyo 100-8324 Japan, its successors, assigns and legal representatives, the entire right, title and interest, in and to all subject matter invented by us and disclosed in the application for Letters Patent of the United States entitled

COMPOUND, RADIATION-SENSITIVE COMPOSITION AND RESIST PATTERN  
FORMATION METHOD

Application Number 13/812,831, filed 01/28/2013 ; and in and to all patent and all convention and treaty rights of all kinds, including the right to claim priority from said application, and all rights in and to any continuation, continuation-in-part, and divisional application therefrom, and any reissue or re-examination as to any patent issuing therefrom, in all countries throughout the world, for all such subject matter described therein, including all rights of action and rights to recover damages for past infringements. We agree to sign all documents necessary to secure all said patents and rights, and request issuance of all said patents to the above assignee in accordance with this assignment.

December 18, 2012

Masatoshi Echigo  
ECHIGO, Masatoshi